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Docket No.

90065.99R272 (17732.6323)

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Applicant:	Jifa Hao,) Examiner:
Serial No.:	09/654,845) O. Nadav
Filed:	September 1, 2000)
For:	POWER SEMICONDUCTOR DEVICE WITH HIGH AVALANCE CAPABILITY AND PROCESS FOR FORMING SAME) Art Unit: 2811))))

RESPONSE TO RESTRICTION REQUIREMENT

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

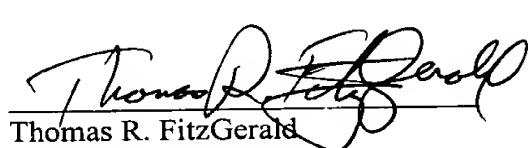
Dear Sir:

In response to the restriction requirement mailed by the U. S. Patent and Trademark Office on December 4, 2001, Applicants elect to prosecute the Group I claims (claims 1-17), drawn to a semiconductor device, without traverse.

Respectfully submitted,

Date

1/4/02


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